



D. Haywood
#31a
6-25-03

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION OF

Confirmation No.: 7533

HORI

Group Art Unit: 1743

Appln. No.: 09/867,418

Examiner: Alexander, Lyle

Filed: May 31, 2001

Title: EVALUATION METHOD FOR POLYCRYSTALLINE SILICON

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AMENDMENT UNDER 37 C.F.R. §1.111

Mail Stop Non-Fee Amendment
Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

Sir:

In reply to the Office Action dated March 27, 2002, please amend the above identified application as follows:

IN THE CLAIMS:

Please amend claims 1, 2, and 5-16 as follows:

Please add claims 17-19 as follows:

1. (Currently amended) An evaluation method for polycrystalline silicon which is used as a material for pulling single crystal silicon, comprising the steps of:

immersing the polycrystalline silicon in an agent which is capable of dissolving the polycrystalline silicon; and

counting the number of foreign particles in the agent using a measuring device.

2. (Currently amended) An evaluation method for polycrystalline silicon as set forth in claim 1, wherein the ~~polycrystalline silicon is used as a material for pulling single crystal silicon~~ measuring device is a particle counter.